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033082M241

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Keisuke Suzuki, et al.

U.S. Serial No.: 10/523,803 ✓

Group Art Unit: 2856

Filed: : February 9, 2005

Examiner: To Be Assigned

For: HEAT TREATMENT METHOD AND HEAT TREATMENT APPARATUS

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the document cited. JP 2001-077041 is cited and discussed on page 2 of Applicants' specification.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

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May 31, 2005

FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET

033082M241

SERIAL NO.

10/523,803

Applicant

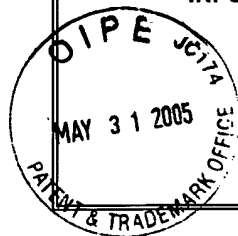
Keisuke Suzuki, et al.

FILING DATE

February 9, 2005

GROUP ART UNIT

2856



U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AF	2001-077041	3/23/01	Japan			Abstract	
	AG							
	AK							
	AH							
	AI							
	AJ							
	AK							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AL	
	AM	
EXAMINER:		DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>		